

<b>Notice of References Cited</b>	Application/Control No. 10/814,971	Applicant(s)/Patent Under Reexamination AGARWAL ET AL.	
	Examiner David Buttner	Art Unit 1712	Page 1 of 1

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*	B	US-5,118,726	06-1992	Mizutani et al.	523/136
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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